

Notice of References Cited	Application/Control No. 10/771,294		Applicant(s)/Patent Under Reexamination IZAWA ET AL.	
	Examiner LOIS ZHENG		Art Unit 1793	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-4,486,241	12-1984	Donofrio, John J.	148/262
*	C	US-4,474,651	10-1984	Yauchi et al.	285/329
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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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